Docket No.: M4065.0319/P319-A

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Husam N. Al-Shareef, et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: July 26, 2001

Examiner: Not Yet Assigned

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET

RAPID THERMAL OXIDATION PROCESS

## FIRST PRELIMINARY AMENDMENT

**Box Non-Fee Amendment** 

Commissioner for Patents Washington, DC 20231

Dear Sir:

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

In the Specification

Page 1, after the title, please insert 1-- This application is a divisional of application Ser. No. 09/296,835, filed on April 22, 1999, which is hereby incorporated by reference.--

In the Claims

Please cancel claims 1-12.

1324023 v1; SDMF01!.DOC 1324023 v1; SDMF01!.DOC